

**Search Notes**

Application/Control No.

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Applicant(s)/Patent under  
ReexaminationVAN HEES, JOHANNES  
LAMBERTUS HENDRIKUS

Examiner

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Art Unit

2829

**SEARCHED**

Class	Subclass	Date	Examiner
324	763,765, 158.1	3/31/2006	AMV

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST Search:US- PGPUB;USPAT;USOCR;EPO;JPO;D ERWENT;IBM_TDB (See Search History Print Out)	3/31/2006	AMV